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Dated: August 31, 2004

Signature: \_\_\_\_\_

Michael R. Hunt

Docket No.: 29936/39429  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Cha D. Dong

Application No.: 10/611,500

Art Unit: 2812

Filed: July 1, 2003

Examiner: Not Yet Assigned

For: METHOD OF FORMING AN ISOLATION  
LAYER IN SEMICONDUCTOR DEVICES

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

**INTRODUCTORY COMMENTS**

Please enter the following amendment in the above-referenced patent application in response to the Office Action mailed on June 2, 2004. The Office Action is a non-final Office Action.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** and a complete listing of the claims begin on page 11 of this paper.

**A proposed drawing change** in the form of a substitute sheet 3 of drawings is attached hereto as an Appendix. The label for Figure "H" has been changed to "1H" to make the label consistent with the other drawings in the case. No new matter is added thereby.

**Remarks/Arguments** begin on page 13 of this paper.